

## EAST Search History

Ref #	Hits	Search Query	DBs	Default Operator	Plurals	Time Stamp
L7	87	((three\$1dimensional "3"\$1d) adj (imaging or image adj capture)).ti. and @py<"2003"	US-PGPUB; USPAT	OR	ON	2007/07/25 09:15
L10	15	(wafer substrate work\$1piece) and shield near7 (light adj scatter\$4) and @py<"2003"	US-PGPUB; USPAT	OR	ON	2007/07/25 10:26
S1	63	plasma adj processing and mitrovic near2 andrej	US-PGPUB; USPAT	OR	ON	2007/07/16 14:23
S3	343	118/723r;315/111.01,111.21,111.414.ccls. and (optic\$4 imag\$4) and magnetic	US-PGPUB; USPAT	OR	ON	2007/07/16 14:38
S4	374	plasma with particles and (optic optical image imaging) and magnetic adj field and (chamber vessel) and (illuminate light laser) with particles and (substrate wafer work\$1piece)	US-PGPUB; USPAT	OR	ON	2007/07/18 09:45
S15	186	deposition and (substrate wafer work\$1piece) and plasma near5 particles and (chamber vessel) and (multiple two plurality) near2 (laser light optic)	US-PGPUB; USPAT	OR	ON	2007/07/17 14:45
S19	63	deposition and (substrate wafer work\$1piece) and (chamber vessel) and ((movable rotatable rotate arc arcuate) near2 (laser light optic)) with axis	US-PGPUB; USPAT	OR	ON	2007/07/17 14:49
S29	20	magnetic adj field near3 (passage passage\$1way) with (light laser)	US-PGPUB; USPAT	OR	ON	2007/07/17 16:28
S34	185	((generate generator) near2 magnetic adj field) near5 (passage passage\$1way hole opening)	US-PGPUB; USPAT	OR	ON	2007/07/17 16:40
S41	991	(color adj filter) near3 (light laser optic) and plasma and (substrate workpiece wafer) and (chamber)	US-PGPUB; USPAT	OR	ON	2007/07/17 17:30
S43	170	(subtractive adj color adj filter)	US-PGPUB; USPAT	OR	ON	2007/07/17 17:31
S44	28	(subtractive adj color adj filter) and plasma	US-PGPUB; USPAT	OR	ON	2007/07/17 17:41
S45	72	(color adj filter) and (substrate wafer work\$1piece) and plasma near5 particles and (chamber vessel)	US-PGPUB; USPAT	OR	ON	2007/07/23 15:10
S49	184	deposition and (chamber vessel) and (substrate wafer work\$1piece) and (prism ((beam light) adj splitter)) and lenses and (light laser) and plasma with particles	US-PGPUB; USPAT	OR	ON	2007/07/18 09:59
S51	1260	deposition and (chamber vessel) and (substrate wafer work\$1piece) and (prism ((beam light) adj splitter)) and lenses and (multiple plurality) near3 (light laser)	US-PGPUB; USPAT	OR	ON	2007/07/18 10:00
S52	195	deposition and (chamber vessel) and (substrate wafer work\$1piece) and (prism ((beam light) adj splitter)) and lenses with (multiple plurality) near3 (light laser)	US-PGPUB; USPAT	OR	ON	2007/07/18 10:11

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S53	134	deposition and (chamber vessel) and (substrate wafer work\$1piece) and ((beam light) adj splitter) and lenses with (multiple plurality) near3 (light laser)	US-PGPUB; USPAT	OR	ON	2007/07/18 10:12
S54	488	multi\$1line adj laser	US-PGPUB; USPAT	OR	ON	2007/07/18 10:27
S55	56	multi\$1line adj laser and plasma and deposition	US-PGPUB; USPAT	OR	ON	2007/07/18 10:28
S56	70	multi\$1line adj laser and deposition	US-PGPUB; USPAT	OR	ON	2007/07/18 10:44
S59	96	(passage passage\$1way hole through\$1hole through) near2 ((magnetic adj field) electrode) with (light laser) and deposition and (substrate wafer) and plasma and @py<"2004" and magnetic adj field	US-PGPUB; USPAT	OR	ON	2007/07/18 11:50
S60	13	(passage passage\$1way hole through\$1hole) near2 ((magnetic adj field) electrode) with (light laser) and deposition and (substrate wafer) and plasma and @py<"2004" and magnetic adj field	US-PGPUB; USPAT	OR	ON	2007/07/18 13:14
S62	141	image adj (morphing warping transforming) and deposition and (substrate wafer work\$1piece)	US-PGPUB; USPAT	OR	ON	2007/07/18 13:30
S64	151	image adj (morphing warping transforming) and plasma and (substrate wafer work\$1piece)	US-PGPUB; USPAT	OR	ON	2007/07/18 13:39
S68	6	image adj (morph\$3 warp\$3 transform\$4). and plasma and (plasma particle) near2 concentration not silverbrook	US-PGPUB; USPAT	OR	ON	2007/07/18 14:32
S69	189	plasma and ((plasma particle) near2 (density concentration)) near5 (measure determine) and (substrate wafer work\$1piece) and magnetic adj field	US-PGPUB; USPAT	OR	ON	2007/07/18 14:35
S70	79	plasma and ((plasma particle) near2 (density concentration)) near5 (measure determine) and (substrate wafer work\$1piece) and magnetic adj field and computer	US-PGPUB; USPAT	OR	ON	2007/07/18 14:38
S71	54	plasma and ((plasma particle) near2 (density concentration)) near5 (measure determine) and (substrate wafer work\$1piece) and magnetic adj field and computer and (laser light)	US-PGPUB; USPAT	OR	ON	2007/07/18 14:38
S72	69	image near3 (morph\$3 warp\$3 transform\$4) and plasma and (particle plasma) near2 (density concentration) and (substrate wafer work\$1piece)	US-PGPUB; USPAT	OR	ON	2007/07/18 14:53
S73	58	((3"\$1D or three\$1dimensional) near5 image) with plasma and @py<"2003" and (substrate wafer work\$1piece)	US-PGPUB; USPAT	OR	ON	2007/07/23 15:18
S74	7	image near4 de\$1project\$4	US-PGPUB; USPAT	OR	ON	2007/07/23 15:18

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S76	13	magnetic adj field adj generator near3 (aperture channel)	US-PGPUB; USPAT	OR	ON	2007/07/23 16:09
S77	947	electrode near3 (aperture channel hole passageway passage through\$1hole) and electrode near5 (magnetic adj field)	US-PGPUB; USPAT	OR	ON	2007/07/25 09:46
S78	241	electrode near3 (aperture channel hole passageway passage through\$1hole) and electrode near5 (magnetic adj field) and (plasma) and (wafer work\$1piece substrate)	US-PGPUB; USPAT	OR	ON	2007/07/23 16:21
S79	151	electrode near3 (aperture channel hole passageway passage through\$1hole) and electrode near5 (magnetic adj field) and (plasma) and (wafer work\$1piece substrate) and @py<"2004"	US-PGPUB; USPAT	OR	ON	2007/07/25 10:09